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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/827,389	04/19/2004	Chung-Cheng Chou	N1085-00209 3133		
8933 7:	590 10/20/2006		EXAMINER		
DUANE MORRIS, LLP			PHAM, LONG		
IP DEPARTMENT 30 SOUTH 17TH STREET			ART UNIT	PAPER NUMBER	
	IIA, PA 19103-4196	•	2814		
			DATE MAILED: 10/20/2006	5	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Applicatio	n No.	Applicant(s)					
Office Action Summary		10/827,38	9 .	CHOU, CHUNG-CHENG					
		Examiner		Art Unit					
		Long Phan	1	2814					
Period fo	The MAILING DATE of this communication r Reply	n appears on the	cover sheet with the c	orrespondence ad	Idress				
WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FOR REHEVER IS LONGER, FROM THE MAILIN asions of time may be available under the provisions of 37 CI SIX (6) MONTHS from the mailing date of this communication period for reply is specified above, the maximum statutory per to reply within the set or extended period for reply will, by eply received by the Office later than three months after the end patent term adjustment. See 37 CFR 1.704(b).	IG DATE OF TH FR 1.136(a). In no eve on. period will apply and will statute, cause the appli	IS COMMUNICATION nt, however, may a reply be timed to the service SIX (6) MONTHS from cation to become ABANDONE	N. nely filed the mailing date of this c D (35 U.S.C. § 133).					
Status									
1)⊠	Responsive to communication(s) filed on	24 July 2006.	. *						
•	·	This action is no	on-final.						
′—	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is								
,—	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
Dispositi	on of Claims								
4)⊠ Claim(s) <u>1,2,4,5 and 7-15</u> is/are pending in the application.									
	4a) Of the above claim(s) <u>8 an d13</u> is/are withdrawn from consideration.								
5)[5) Claim(s) is/are allowed.								
6)⊠									
7)									
. 8)	Claim(s) are subject to restriction a	and/or election re	quirement.	•					
Applicati	on Papers								
9)	The specification is objected to by the Exa	miner.							
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.									
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).									
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).									
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.									
Priority ι	ınder 35 U.S.C. § 119								
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).									
· a)	 a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 								
	3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).								
* See the attached detailed Office action for a list of the certified copies not received.									
Attachmen	t(e)								
1) Notice of References Cited (PTO-892) 4) Interview Summary (PTO-413)									
2) Notic	e of Draftsperson's Patent Drawing Review (PTO-94	8)	Paper No(s)/Mail Da	ate					
. —	nation Disclosure Statement(s) (PTO/SB/08) r No(s)/Mail Date		5) Notice of Informal F 6) Other:	ratent Application					

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DETAILED ACTION

Rejections and/or objections necessitated by the amendments Claim Rejections - 35 USC § 103

The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claims 1-2, 4-5, 7, 9-12, 14, and 15 are rejected under 35 U.S.C. 103(a) as being unpatentable over the applicant's admitted prior art (AAPA) of this application in combination with Afgabi et al. (US publication 2003/0095427) and Lawlor (US pub 2004/0043587).

With respect to claims 1, 2, 7, 12, AAPA teaches a single transistor random access memory cell, comprising (see fig. 1 and the Field of the Invention):

A transfer gate 120; and

A storage capacitor with a storage node 150.

AAPA fails to teach that the storage node has an MOS native device.

Afgabi et al. teach a storage node having an MOS native device to reduce the charge leakage. See [0004] and [0005].

It would have been obvious to one of <u>ordinary skill</u> in the art of making semiconductor devices to incorporate the above teaching of Afbabi et al. into the device of AAPA to achieve the above benefit.

Further with respect to claims 1, 2, 7, and 12, since AAPA in combination with AAPA teach the claimed structure, an inversion layer having a near zero threshold voltage would inherently be formed under beneath the transfer gate.

Further with respect to claims 1, 2, 7, and 12, how the inversion layer is formed has not been given patentable weight since claims are directed to a device.

Further with respect to claim 1, AAPA further teaches a shallow trench isolation, STI, insulator 110 having a step height below that of a sidewall of a substrate insulator (the insulator between the capacitor plate 130 and substrate

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100 and the capacitor plate 130 covering the STI insulator and the sidewall. See fig. 1 and associated text of AAPA.

AAPA fails to teach that at least the sidewall of the substrate insulator is doped.

Lawlor teaches doping an insulator to increase its conductivity. See claim 11.

It would have been obvious to one of <u>ordinary skill</u> in the art of making semiconductor devices to incorporate the above teaching of Lawlor into the device of AAPA to achieve the above benefit.

With respect to claims 4, 9, and 14, AAPA further teaches that the transfer gate 120 and a capacitor plate 130 is being closer together than a minimum line width of a layer.

With respect to claims 5, 10, and 15, AAPA further teach a air spacer between the transfer 120 and capacitor plate 130 but fails to tech the spacer is made of dielectric.

However, the use of dielectric as insulating spacer or spacing is well-known.

Further with respect to claim 11, AAPA further teaches a shallow trench isolation, STI, insulator 110 having a step height below that of a sidewall of an insulator between the capacitor plate and substrate. See fig. 1 and associated text of this application.

Further with respect to claim 11, AAPA further teaches the transfer gate 120 and the capacitor are being in an active area of the substrate. See fig. 1 and associated text of this application.

Further with respect to claim 11, AAPA fails to teach an external MOS native device.

Afgabi et al. teach including an MOS native device to reduce the charge leakage. See [0004] and [0005].

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Further with respect to claim 11, AAPA in combination Afgabi et al. further teach the capacitor plate covering the STI insulator and the external MOS native device.

It would have been obvious to one of <u>ordinary skill</u> in the art of making semiconductor devices to include an MOS native device in the device of Afbabi et al. to achieve the above benefit.

Further with respect to claim 11, AAPA in combination with Afgabi et al. further teach that the capacitor plate covering the STI insulator 110 and plate would inherently cover the MOS native device if incorporated into the device of AAPA.

Response to Arguments

Applicant's arguments with respect to claims 1-2, 4-5, 7, 9-12, 14, and 15 have been considered but are most in view of the new ground(s) of rejection.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Long Pham whose telephone number is 571-272-1714. The examiner can normally be reached on Mon-Frid, 10am to 5pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on 571-272-1705. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA @R CANADA) or 571-272-1000.

Long Pham

∕Primary Examiner

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